



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Martin Behringer et al. Art Unit : 2811
Serial No. : 09/787,186 Examiner : Shouxiang Hu
Filed : May 17, 2001
Title : SEMICONDUCTOR COMPONENT CONTAINING LATTICE MISMATCHED
SEMICONDUCTOR MATERIALS

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF JULY 19, 2005

Please amend the above-identified application as follows:

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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